

08-28-2001



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Tomonobu NODA and Tatsuo AKIYAMA

8/17/01

## 2. Name and address of receiving party(ies):

Name: KABUSHIKI KAISHA TOSHIBA

Address: 1-1 Shibaura 1-chome, Minato-ku, Tokyo  
JapanAdditional name(s) of conveying party(ies) attached? ☐ Yes ☒ No

## 3. Nature of Conveyance:

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Execution Date: August 8, 2001

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## 4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: August 8, 2001

A. Patent Application No.(s)

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Additional numbers attached? ☐ Yes ☒ No

5. Name and address of party to whom correspondence concerning document should be mailed:

6. Total applications and patents involved: 1

7. Total fee (37 CFR 3.41): \$40.00

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In consideration of value received, I, having a mailing address at  
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next to my name, the sole inventor (if only one name is listed below)  
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## METHOD OF EVALUATING CRITICAL LOCATIONS ON A SEMICONDUCTOR APPARATUS PATTERN

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# A S S I G N M E N T

01S0291

Inventor: (Signature)

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